

FIG. 1

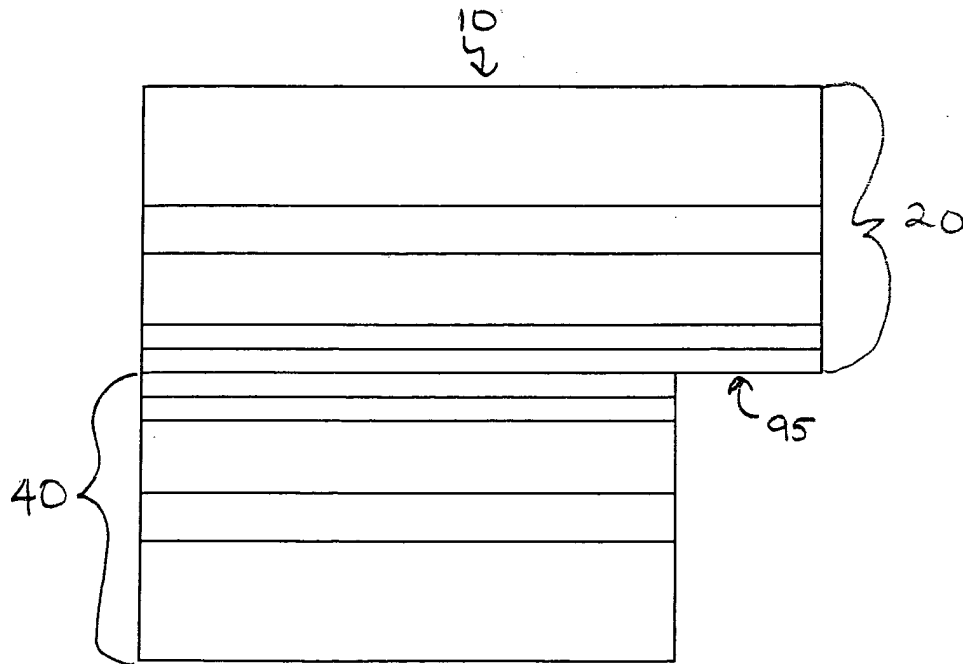
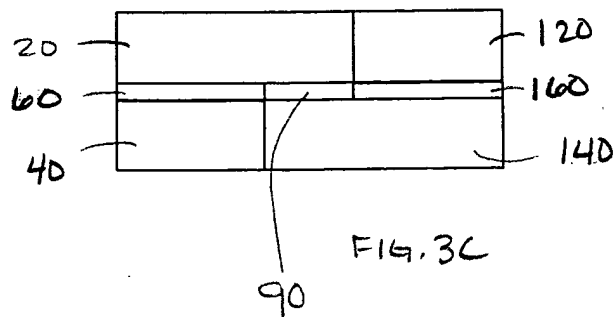
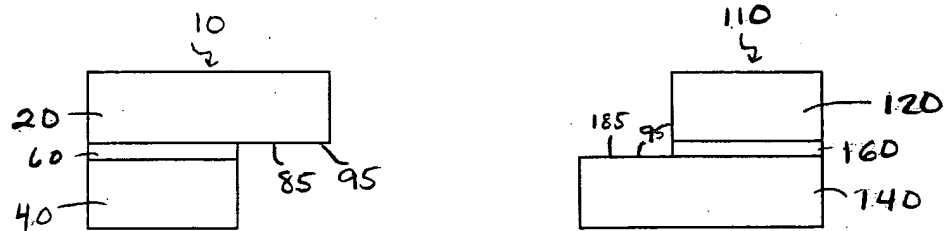
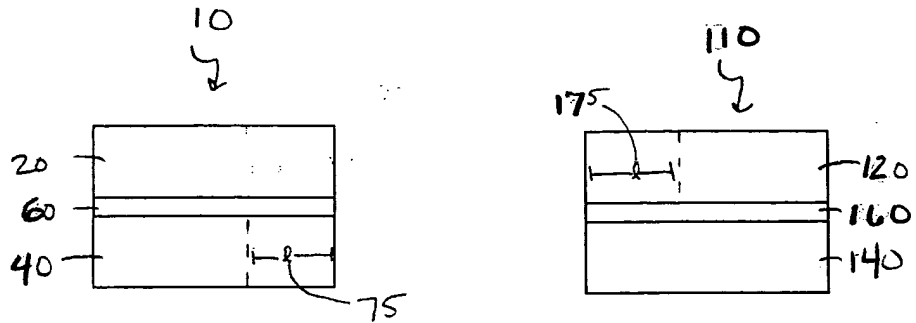


FIG. 2



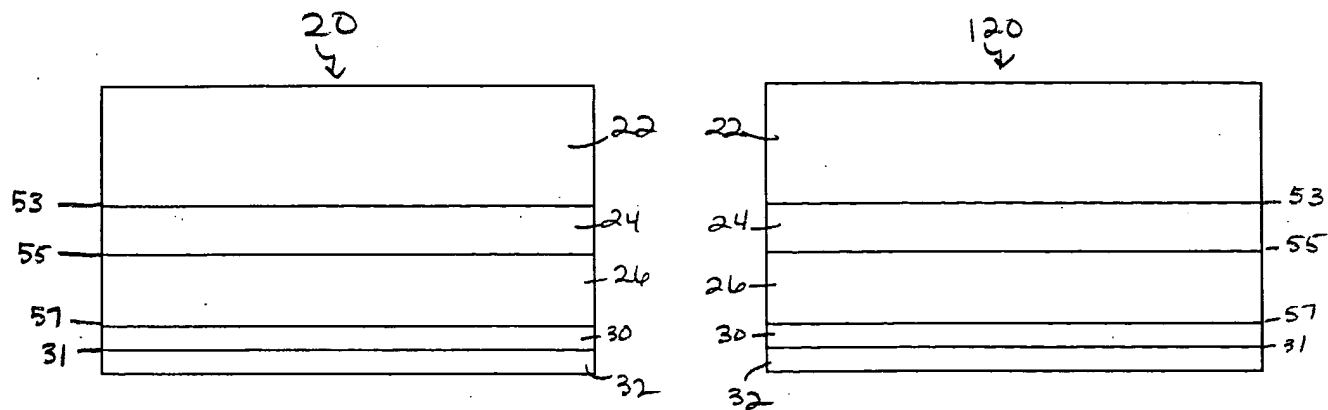


FIG. 4A

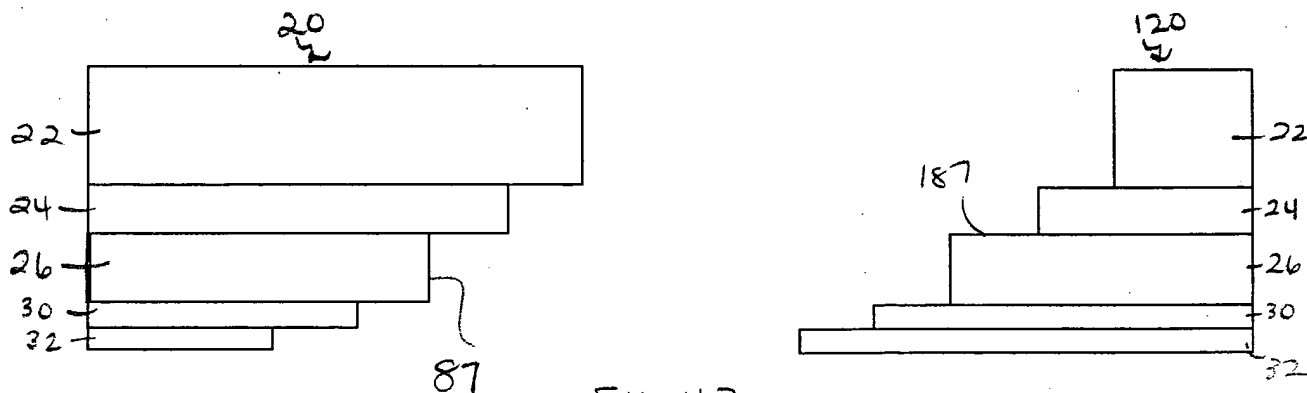


FIG. 4B

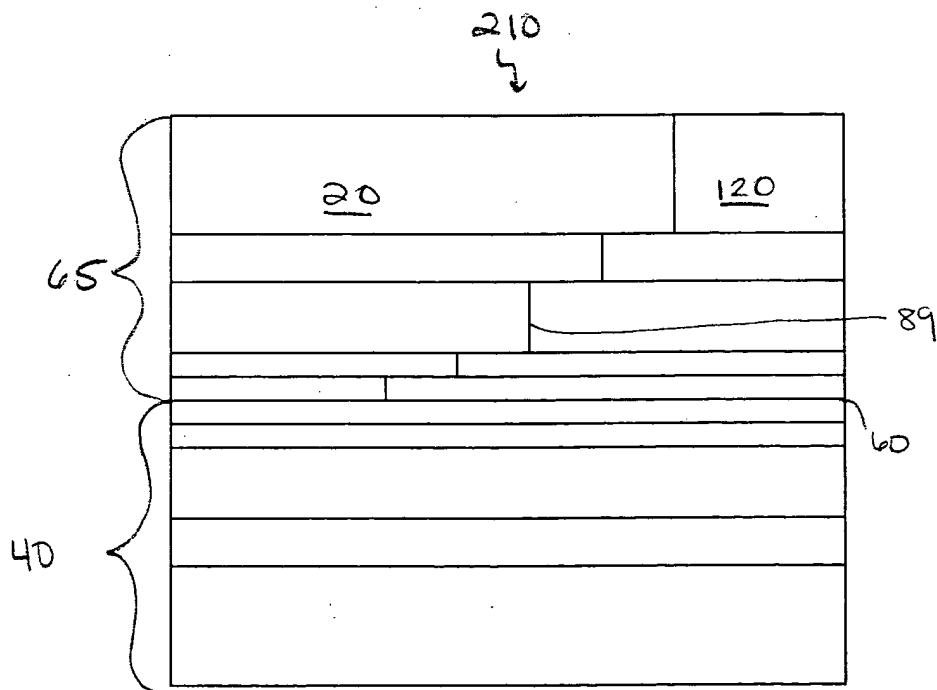
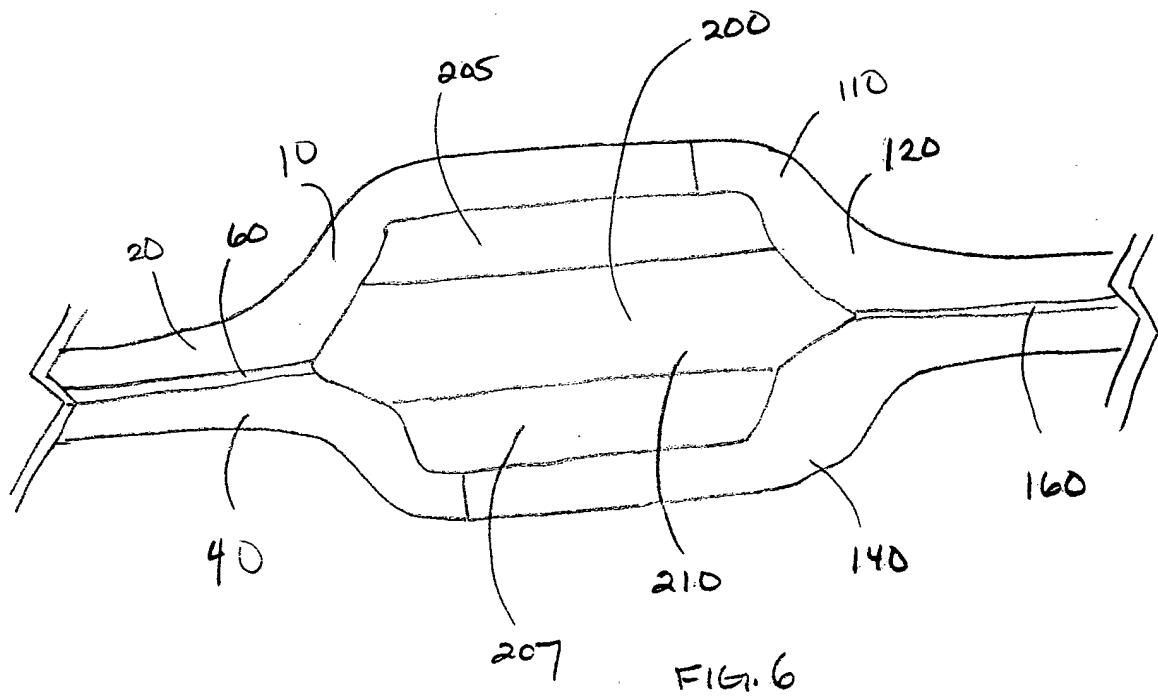
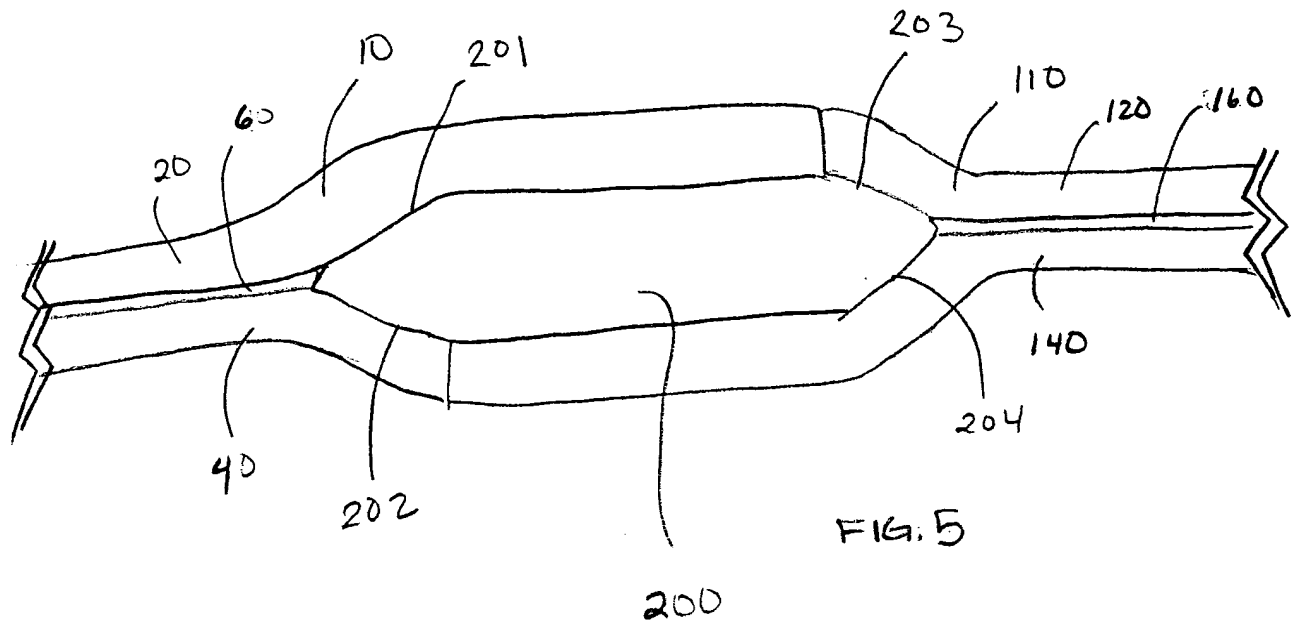


FIG. 4C



Applicant(s): Malozemoff et al.

HIGH TEMPERATURE SUPERCONDUCTING DEVICES AND
RELATED METHODS

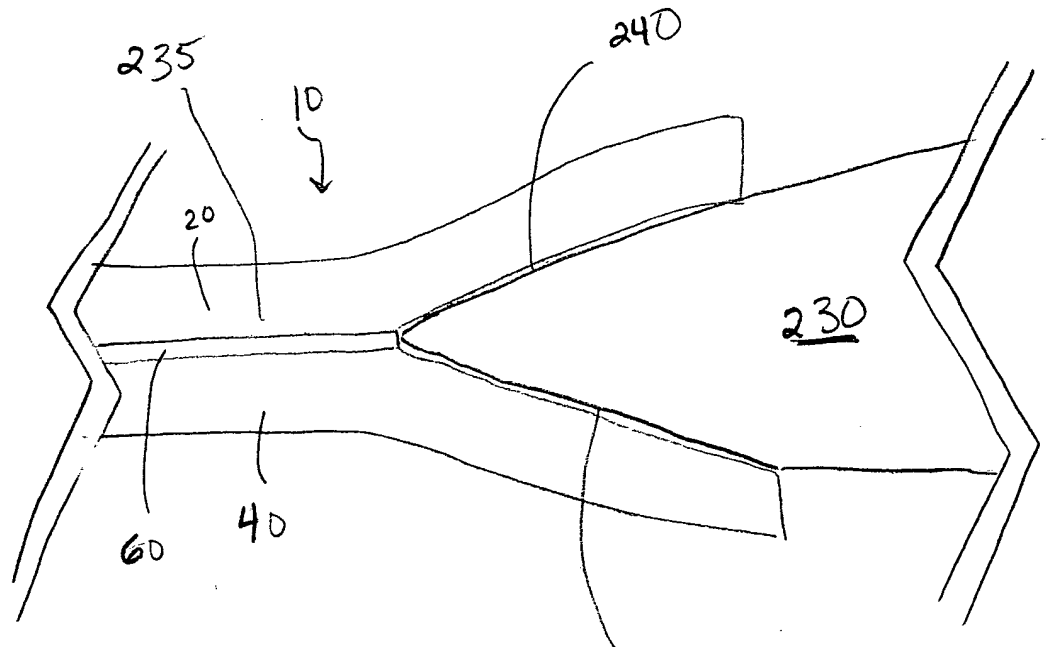


FIG. 7

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